

IN THE SPECIFICATION:

Please amend paragraph [0001] as follows:

[0001] The present application is related to a new U.S. Patent Application, filed concurrently, to Chen et al., entitled "A METHOD OF PREVENTING SURFACE ROUGHENING DURING HYDROGEN PREBAKE OF SIGE SUBSTRATES", having ~~(IBM)~~ Docket No. FIS920030173 U.S. Patent Application Serial Number 10/751,208, assigned to the present assignee, and incorporated herein by reference.

10/751,207